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SERIAL NUMBER 10/755,395	FILING DATE 01/13/2004  RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 843.43390X00	
APPLICANTS  Mikio Shimizu, Higashiibaraki, JAPAN;  ** CONTINUING DATA ***** None <i>S.W.S.</i>  ** FOREIGN APPLICATIONS ***** <i>S.W.S.</i> JAPAN 2003-023151 01/31/2003  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/14/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>S.W.S.</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 2
ADDRESS 020457 ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800 ARLINGTON, VA 22209-3873					
TITLE METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE USING THERMAL TREATMENT THAT FEATURES LOWER SPEED WAFER ROTATION AT LOW TEMPERATURES AND HIGHER SPEED WAFER ROTATION AT HIGH TEMPERATURES					
FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		